

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application		OFGS File No. 711785289 P72850-144		
		Applicant Takeshi NAKAMURA				
		Filing Date		Group Art Unit		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-2001/0008067 A1	07-2001	Liebig	60	39.02	
	US-6,368,663 B1	04-2002	Nakamura et al.	427	248.1	
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes
	JP 10-194856	07-1998	Japan			abstract
	P2003-20287	01-2003	Japan			abstract
	EP 1 277 716 A1	01-2003	Europe			
	63-012671	01-1988	Japan			abstract
	P2000-219576	08-2000	Japan			abstract
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		International Search Report PCT/JP2004/019518 dated 29 March 2005				
Examiner		Date Considered				
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